

<b>Notice of References Cited</b>	Application/Control No. 10/806,260	Applicant(s)/Patent Under Reexamination KIEL ET AL.	
	Examiner Yevgeny Valenrod	Art Unit 1621	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,383,471	05-2002	Chen et al.	424/45
*	B	US-2004/0192616	09-2004	Kiel et al.	514/023
*	C	US-2004/0192617	09-2004	Kiel et al.	514/023
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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